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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/813,233	03/31/2004	Shunpei Yamazaki	740756-2719	3870
22204	7590 06/29/2005	EXAMINER		INER
NIXON PEABODY, LLP			DANG, TRUNG Q	
401 9TH STREET, NW SUITE 900			ART UNIT	PAPER NUMBER
WASHINGTO	ON, DC 20004-2128		2823	
			DATE MAILED: 06/29/2009	5

Please find below and/or attached an Office communication concerning this application or proceeding.

	1	Application No.	Applicant(s)				
Office Action Summary		10/813,233	YAMAZAKI ET AL.				
		Examiner	Art Unit				
·		Trung Dang	2823				
The MAILING DATE of this cor Period for Reply	nmunication appea	ars on the cover sheet t	vith the correspondence add	ress			
A SHORTENED STATUTORY PERITHE MAILING DATE OF THIS COM Extensions of time may be available under the proafter SIX (6) MONTHS from the mailing date of the lifthe period for reply specified above is less than If NO period for reply is specified above, the maxiful Failure to reply within the set or extended period for Any reply received by the Office later than three mearned patent term adjustment. See 37 CFR 1.70	MUNICATION. visions of 37 CFR 1.136(s communication. thirty (30) days, a repty w mum statutory period will or repty will, by statute, ca nonths after the mailing da	a). In no event, however, may a atthin the statutory minimum of the apply and will expire SIX (6) MC ause the application to become a	a reply be timely filed airty (30) days will be considered timely. DNTHS from the mailing date of this com ABANDONED (35 U.S.C. § 133).	nmunication.			
Status							
1) Responsive to communication	s) filed on 13 Apri	il 2005.	•				
2a)⊠ This action is FINAL .	· · · · · · · · · · · · · · · · · ·						
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Disposition of Claims							
4) ⊠ Claim(s) <u>1 and 3-18</u> is/are penda 4a) Of the above claim(s) 5) □ Claim(s) is/are allowed. 6) ⊠ Claim(s) <u>1 and 3-18</u> is/are rejee 7) □ Claim(s) is/are objected 8) □ Claim(s) are subject to a	_ is/are withdrawr cted. to.	from consideration.					
Application Papers							
9)☐ The specification is objected to	by the Examiner.						
10) ☐ The drawing(s) filed on is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.							
Applicant may not request that an	Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).						
Replacement drawing sheet(s) inc 11) The oath or declaration is object	•	•	• • •	, ,			
Priority under 35 U.S.C. § 119							
12) Acknowledgment is made of a capplication from the Interest of the act and a capplication from the Interest of the act act and act	of: ionty documents ionty documents opies of the priont rnational Bureau (have been received. have been received in y documents have bee (PCT Rule 17.2(a)).	Application No n received in this National S	Stage			
Attachment(s)	·						
1) Notice of References Cited (PTO-892)	description of the		Summary (PTO-413)				
 Notice of Draftsperson's Patent Drawing Re Information Disclosure Statement(s) (PTO-1 Paper No(s)/Mail Date 4/12/05. 			o(s)/Mail Date f Informal Patent Application (PTO- 	152)			

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DETAILED ACTION

Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in a patent granted on an application for patent by another filed in the United States before the invention thereof by the applicant for patent, or on an international application by another who has fulfilled the requirements of paragraphs (1), (2), and (4) of section 371(c) of this title before the invention thereof by the applicant for patent.

The changes made to 35 U.S.C. 102(e) by the American Inventors Protection Act of 1999 (AIPA) and the Intellectual Property and High Technology Technical Amendments Act of 2002 do not apply when the reference is a U.S. patent resulting directly or indirectly from an international application filed before November 29, 2000. Therefore, the prior art date of the reference is determined under 35 U.S.C. 102(e) prior to the amendment by the AIPA (pre-AIPA 35 U.S.C. 102(e)).

2. Claims 1, 3-18 are rejected under 35 U.S.C. 102(e) as being anticipated by Yamazaki et al. (US 6,246,070 of record)

The applied reference has a common inventor with the instant application.

Based upon the earlier effective U.S. filing date of the reference, it constitutes prior art under 35 U.S.C. 102(e). This rejection under 35 U.S.C. 102(e) might be overcome either by a showing under 37 CFR 1.132 that any invention disclosed but not claimed in

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related text);

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the reference was derived from the inventor of this application and is thus not the invention "by another," or by an appropriate showing under 37 CFR 1.131.

With reference to Figs. 1A-2E, the prior art teaches the claimed invention in that it discloses a method for manufacturing a semiconductor device comprising the steps of:

forming a gate electrode 102 over a substrate;
forming a gate insulating films 103 over the gate electrode;
forming a semiconductor film 104 over the gate insulating film;
forming an insulating film 105 over the semiconductor film 104 (Fig. 1B and

crystallizing said semiconductor film by irradiating it with infrared light or ultraviolet light through said insulating film 105 to form a crystalline semiconductor film (bottom of col. 8); and

covering a region to become a channel formation region of said crystalline semiconductor film with a first mask 109a and doping a region to become a source region or drain region of said crystalline semiconductor film with a trivalent or pentavalent impurity element through said insulating film 105; covering a portion of the first mask 109a and either a portion of the source region or a portion of the drain region with a second mask 112; and forming an interlayer insulating film 117 over the first mask and the second mask.

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Note that the claimed limitation "covering a portion of the first mask and either a portion of the source region or a portion of the drain region with a second mask" does not exclude the second mask covering an entire surface the first mask and both of a portion of a source region and a portion of a drain region. All that is specified by the limitation is the second mask cover a portion of the first mask (the entire surface of the first mask includes a portion thereof) and a portion of either source region or drain region, which does not necessarily excluding covering both. Therefore, as shown in Fig. 2A, the second mask does cover a portion of source (or drain) region.

For claims 3 and 11, see col.5, lines 31-34 and claim 23 of the reference. Note that a hydrogen compound is a hydride.

For claims 4 and 12, see col. 5, lines 35-37 and claim 24 of the reference.

For claims 5 and 13, see col. 5, lines 38-41 and claim 25 of the reference.

For claims 7-9, see cols. 7-8 for embodiments which disclose the limitations of claims 7-9.

For claim 10, see Embodiment 2 in col. 13, lines 21-23 in which a catalytic element for promoting crystallization of silicon is used.

Response to Arguments

3. Applicant's arguments with respect to claims 1, 6, and 16 have been considered but are most in view of the new ground(s) of rejection.

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4. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Trung Dang whose telephone number is 571-272-1857. The examiner can normally be reached on Mon-Friday 9:30am-6:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Olik Chaudhuri can be reached on 571-272-1855. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Trung Dang Primary Examiner Art Unit 2823

06/27/05